



APPLICATION DATA SHEET (ADS)

APPLICATION INFORMATION

Application Type::	Regular
Subject Matter::	Utility
Title::	ELECTRON BEAM APPARATUS HAVING ELECTRON ANALYZER AND METHOD OF CONTROLLING LENSES
Attorney Docket Number::	116-040128
Request for Early Publication?::	No
Request for Non-Publication?::	No
Suggested Drawing Figure::	8
Total Drawing Sheets::	7
Small Entity?::	No
Secrecy Order In Parent Appl.?::	No

APPLICANT INFORMATION

Applicant Authority Type::	Inventor
Primary Citizenship Country::	Japan
Status::	Full Capacity
Given Name::	Toshikatsu
Middle Name::	
Family Name::	Kaneyama
Name Suffix::	
State or Prov. of Residence::	Tokyo
Country of Residence::	Japan
Street of Mailing Address::	1-1, Ogawahigashi 2-chome
City of Mailing Address::	Akiruno
State or Prov. of Mailing Address::	Tokyo
Postal or Zip Code::	197-0822

CORRESPONDENCE INFORMATION

Correspondence Customer Number::	28289
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REPRESENTATIVE INFORMATION

Representative Customer Number::	28289	
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FOREIGN PRIORITY INFORMATION

Country::	Application number::	Filing Date::	Priority Claimed::
Japan	2003-14751	January 23, 2003	Yes

ASSIGNMENT INFORMATION

Assignee Name::	JEOL Ltd.
Street of mailing address::	1-2, Musashino 3-chome
City of mailing address::	Akishima
State or Prov. of Mailing Address::	Tokyo
Country of Mailing Address::	Japan
Postal or Zip Code::	196-8448